

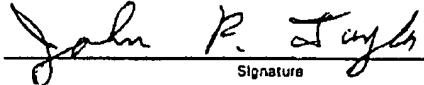
Appl. No. 10/006,398
Amendment dated January 07, 2004
Reply to Office Action of October 8, 2003

Docket No. 01-234

#4
Amata
TV 3-25-04

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Colin D. Yates, Nicholas F. Pasch, and Nicholas K. Eib
Appl. No. : 10/006,398
Filed : November 30, 2001
Title : ALIGNMENT PROCESS FOR INTEGRATED CIRCUIT
STRUCTURES ON SEMICONDUCTOR SUBSTRATE USING
SCATTEROMETRY MEASUREMENTS OF LATENT IMAGES IN
SPACED APART TEST FIELDS ON SUBSTRATE
Grp./ A.U. : 2877
Examiner : Layla G. Lauchman
Docket No. : 01-234

CERTIFICATE OF MAILING	
I hereby certify that this amendment is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date shown below:	
on	<u>January 07, 2004</u>
(Date of Mailing)	
John P. Taylor, Reg. No. 22,369	
 _____ Signature	
<u>January 07, 2004</u>	
_____ Date of Signature	

AMENDMENT

Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: January 07, 2004

Sir:

In response to the Office Action of October 8, 2003, please amend the above-identified
application as follows: